

Rocking the Pocket Book: Hacking Chemical Plants for Competition and Extortion

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(Ex)Academic

Hacker

Got hooked on cyberphysical hacking

Dragged into academic world against own will







Industrial Control Systems

Industrial Control Systems aka SCADA



Industrial Control Systems

Industry means big business Big business == \$\$\$\$\$\$



Here's a plant. What is the plan?



Attack scenario: persistent economic damage

How do we do it??

Some horrible physical consequences



Typical understanding of SCADA hacking



Source: simentari.com

What can be done to the process

Equipment damage

- **Equipment overstress**
- Violation of safety limits

Production damage

- Product quality and product rate
- Operating costs
- Maintenance efforts

Compliance violation

- Safety (occupational, environment)
- **D** Pollution (environment)
- **Contractual agreements**









Process control



(Nest because it's so cute!)

Running upstairs to turn on your furnace every time it gets cold gets tiring after a while so you automate it with a thermostat

Set point



Control loop



Control system









$$\mathbf{u}(t) = \mathbf{MV}(t) = K_p e(t) + K_i \int_0^t e(\tau) \, d\tau + K_d \frac{d}{dt} e(t)$$

- PID: proportional, integral, derivative most widely used control algorithm on the planet
- Sum of 3 components make final control signal
- Full PID control is hard(er) and used for tight control (e.g. temperature in the reactor)
 Jacques Smuts "Process Control for Practitioners"



- Obviously control logic gets more complex than a thermostat
- You'll need something bigger than a thermostat to handle it all
- Most of the time this is a programmable logic controller (PLC)
- □ It is programmed graphically most of the time







Computer scientists: Noooooooo!!!! Just give me a real language!





Field communication

- o 4-20 mA
- o 0-10 v
- Air pressure

Usually process values are scaled into meaningful data in the PLC



Wires are run from sensors and actuators into wiring cabinets



PLC does not have the complete picture and time trends
 Human operators watch the process 7/24





IT hacking vs. OT hacking













You can do unfocused and uncontrolled magic without a wand but to do really good spells, yes, you need a wand. Joanne Rowling, 2001

- An attacker with an objective beyond simple mayhem will want to reliably manipulate the process
- This is achieved by obtaining and remaining in control of the process
- In the context of OT hacking the "focused magic" is achieved with control theory methods

Example: attack on process data flow





Controllability





- During the attack the hacker herself must be process engineer, control engineer and process operator
- Process operator and hacker rival for control over the process



Process-related security properties



IT domain

Process control



IT domain

Process control



HOLY TRINITY





CIA

Information security

Process control security

Haters gonna hate...



Process control challenges

- There are some things in a process that are impossible to understand or model
- All is not lost, the process can still be (controllably) destabilized



Consider a car and a driver

- The attacker wants to drive the car off the road
 - She has control of the brakes
- The attacker closes the left front brake 100% and the car pulls to the left
- The driver compensates by steering to the right eventually coming back into a straight line



Consider a car and a driver

- The attacker responds by letting go of the left brake and applying the right brake 100%
- The driver responds by steering to the right until the car is straight again
- The attacker responds by swapping back and forth between the brakes



The driver responds by steering back and forth to the rhythm of the brakes keeping the car more-or-less straight



- The attacker responds by swapping brakes whenever the driver starts to compensate
- Eventually the attacker will win since a computer is faster than a human



Multi-adaptive

- In the example above, the human is the "hidden actor" in the process that can't be modeled or predicted
- Any subset of a process can be modeled as a "hidden actor" and potentially destabilized
- We call the algorithms that counter the feedback loops in the process "multiadaptive" algorithms




- Multi-Adaptive algorithms work just like PID autotuners except they try to maximize the error instead of minimizing it
- The algorithm learns the behavior of the hidden actor and then compensates for it
- **Everything the control loop does makes things worse**







Adjust the slope of AB to maximize overshoot



$U_{i}(t)=K/T_{i}*Sum(e(t)+u(0))$



If that fails, adjust period of AB->AB maximizing the running total error



$U_d(t) = KT_d^* de(t)/dt$



If that fails, adjust the rate of period change to maximize the angle between AB and CD



<Robotic arm demo here>



- A single algorithm can be used as a payload to disrupt many types of processes
- Crash a car or overpressure a loop
- Correlation engines can be used to automatically pair actuators with sensors
- Think of this as process "fuzzing"



Get the party started!



It is not about the size







It is about MONEY Plants are ouch! how expensive

Plants for sale

From LinkedIn, really ;-)



Used VAM - Vinyl Acetate Monomer plant for sale & relocation! If any interest, please contact me!

+ Follow Tommy + Follow Tommy

Like · Comment (4) · Share · Follow · 3 more



Vinyl Acetate Monomer plant (model)





Stages of cyber-physical attacks

Attack objective





Stages of SCADA attack

adieri



UTT

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Stages of SCADA attack

in heri



UTT



Access

Traditional IT hacking



- AntiVirus and patch management
- Database links
- Backup systems



- Converts analog signal into digital
- Sensors pre-process the measurements
- May send data directly to actuators
- □ IP-enabled (part of the "Internet-of-Things")







Discovery

Process discovery



What and how the process is producing

Espionage



How it is controlled Espionage, reconnaissance Espionage, reconnaissance



How it is build and wired

Process discovery



Process discovery

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Stripper is...



Stripping column



Max economic damage?



Reaction

Available controls

Vinyl Acetate Monomer Process



HAc flows into two sections. Not good :(

Understanding points and logic

Programmable Logic Controller



Piping and instrumentation diagram

Ladder logic





Pump on the plant

Available controls



Available controls



Obtaining control != being in control

- Obtained controls might not be useful for attack goal
- Attacker might not necessary be able to control obtained controls





Control

Physics of process control

- Once hooked up together, physical components they become related to each other by the physics of the process
- If we adjust one a valve what happens to everything else?
 - Adjusting temperature also increases pressure and flow
 - All the downstream effects need to be taken into account
- How much does the process can be changed before releasing alarms or it shutting down?



Process control challenges

Process dynamic is highly non-linear (???)



- Behavior of the process is known to the extent of its modelling
 - So to controllers. They cannot control the process beyond their control model





Types of attacks



Outcome of the control stage

Sensitivity	Magnitude of manipulation	Recovery time			
High	XMV {1;5;7}	XMV {4;7}			
Medium	XMV {2;4;6}	XMV {5}			
Low	XMV{3}	XMV {1;2;3;6}			
	Reliably useful controls				
Alarm propagation

Alarm	Steady state attacks	Periodic attacks
Gas loop 02	XMV {1}	XMV {1}
Reactor feed T	XMV {6}	XMV {6}
Rector T	XMV{7}	XMV{7}
FEHE effluent	XMV{7}	XMV{7}
Gas loop P	XMV{2;3;6}	XMV{2;3;6}
HAc in decanter	XMV{2;3;7}	XMV{3}

To persist we shall not bring about alarms

Outcome of the control stage





We should automate this process (work in progress)



Damage

How to break things?

- Attacker needs one or more attacks scenarios to deploy in final payload
- The least familiar stage to IT hackers
 - In most cases requires input of subject matter experts
- Accident data is a good starting point
 - Governmental agencies
 - Plants' own data bases
- Requires a metric/measure to compare between scenarios





The New York Times

Technician vs. engineer

Technician

"It will eventually drain with the lowest holes loosing pressure last"



Engineer

"It will be fully drained in 20.4 seconds and the pressure curve looks like this"

Process observation

A 11



Technician answer





Reactor with cooling tubes



If you can't measure it, you can't manage it Peter Drucker

Quest for engineering answer

Code in the controller

- Optimization applications
- Test process/plant



Engineering answer





Product loss

Product loss per day: 11.469,70\$



NOT BAD

Outcome of the damage stage

Product per day: 96.000\$

Product loss, 24 hours	Steady-state attacks	Periodic attacks
High, ≥ 10.000\$	XMV {2}	XMV {4;6}
Medium, 5.000\$ - 10.000\$	XMV {6;7}	XMV {5;7}
Low, 2.000\$ - 5.000\$	-	XMV {2}
Negligible, ≤ 2.000\$	XMV {1;3}	XMV {1;2}

Still might be useful



Clean-up



Creating forensics footprint

- Process operators may get concerned after noticing persistent decrease in production and may try to fix the problem
- If attacks are timed to a particular employee shift or maintenance work, plant employee will be investigated rather than the process



Creating forensics footprint

- 1. Pick several ways that the temperature can be increased
- 2. Wait for the scheduled instruments calibration
- 3. Perform the first attack
- Wait for the maintenance guy being yelled at and recalibration to be repeated
- 5. Play next attack
- 6. Go to 4



Creating forensics footprint



Defeating chemical forensics

- If reactor doubted, chemical forensics guys will be asked to assist
- Know metrics and methods of chemical investigators!
- Change attack patterns according to debugging efforts of plant personnel





Afterword



Please rate your hacking experience



Cost of attack vs. cost of damage

Medium effort

- SCADA access stage is (well) understood and facilitated by tools
 - ICS-CERT and multiple public presentations
 - SCADA access for sale

Medium to high effort

Discovery stage has started long time ago and goes on

- Hackers know more about the process than process owners
- First field equipment reconnaissance malware is caught in wild



Cost of attack vs. cost of damage

High effort

Control stage

- Requires established approaches for mapping and storing dynamic behavior of the process and interdependencies
- Our work in progress

Damage stage

- Requires involvement of subject matter experts
- Several public damage attack instances
- Our work in progress
- Clean-up stage is understood by attackers
 - Several public presentations
 - The defenders are too busy setting up firewalls

Cost of attack vs. cost of damage

Cost of attack can quickly exceed cost of damage

- Hacking into large number of devices
- Suppression of alarms and process data spoofing
- o Badly behaved control loops , synchronization of actions
- Inclusion of several attacks scenarios

Each process is unique, but...

- There is a number of tasks needed to done for each process
- There is a number of issues similar to different processes
- There are instances of attacks applicable to wide range of scenarios
- **SCADA payloads for Metasploit is just a matter of time**

Research agenda

- Developing of light-weight real time algorithms for various tasks
- Working out breakage scenarios





If you plan to improve your financial posture, is a good time (and at least next 5 year as well)







Thank you

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Damn Vulnerable Chemical Process

TE: http://github.com/satejnik/DVCP-TE **VAM:** http://github.com/satejnik/DVCP-VAM